

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date December 28, 2001

In re the Application of

Akira SATO

Application No.: 09/424,500

Filed: February 22, 2000

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, MOLDING DEVICE FOR SEMICONDUCTOR DEVICE, AND SEMICONDUCTOR DEVICE



Group Art Unit: 2825

Examiner: G. Lee, Jr.

Docket No.: 104788

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**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired November 28, 2001, an extension of time for a period of one month is hereby requested. Attached hereto is our Check No. 126426 in the amount of \$110.00 in payment for:

XX Extension fee for response within first month pursuant to §1.136(a) (\$110.00)
_____ Extension fee for response within second month pursuant to §1.136(a) (\$400.00)
_____ Extension fee for response within third month pursuant to §1.136(a) (\$920.00)

The Director is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

James A. Oliff

James A. Oliff
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JAO:BMH/gpn

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